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Our Docket: 362-39

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TO:	Examiner Wai-Sing Louie Group Art Unit: 2814		
FAX NO.:	703-308-7722		
FROM:	Rod S. Turner		
SENDER:	Inlie I. Watts		

# HOFFMANN & BARON, LLP ATTORNEYS AT LAW

• NY OFFICE	NJ OFFICE
6900 JERICHO TURNPIKE	1055 PARSIPPANY BOULEVARD
SYOSSET, N.Y. 11791	PARSIPPANY, N.J. 07054
TELEPHONE: 516-822-3550	TELEPHONE: 973-331-1700
TELECOPIER: 516-822-3582	TELECOPIER: 973-331-1717
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#### **PATENT**

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)	Katsumi Sameshima	Examiner:	Wai-Sing Louie	
Serial No.:	09/451,979	Group Art Unit:	2814	
Confirmation No.:	Unassigned	Docket:	362-39	
Filed:	November 30, 1999	Dated:	February 13, 2002	
For:	FERROELECTRIC MEM AND METHOD FOR MANUFACTURING SAM			
Commissioner for Patents Washington, DC 20231		Certificate of Facsimile Transmission  I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below:		
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# DRAFT PROPOSED AMENDMENT

Sir:

In response to the final Office Action mailed October 19, 2001, a reply to which is due February 19, 2002 with a Petition for Extension of Time, the following amendments are proposed:

## IN THE CLAIMS:

Please amend Claims 1 -5 by rewriting the same as follows:

1. (Twice Amended) A ferroelectric memory, comprising:
an insulation film having a [hollow] concave portion at a top surface; and
a laminated body obtained by laminating a plurality of layers on said top surface and
etching a region of said plurality of layers corresponding to a region other than said [hollow]
concave portion wherein said laminated body includes a lower electrode layer which is
cought into contact with a nottom surface of said concave portion. Corresponding to a region other than said [hollow]
formed on said lower electrode layer and an upper electrode layer tormed on said
ferroelectric layer, wherein a portion of said lower electrode layer protrudes outward from an